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Under the Paperwo Substitute for for Interior Complete if Known 10/028,288 Application Number INFORMATION DISCLOSURE Filing Date December 28, 2001 STATEMENT BY APPLICANT James A. Tatum First Named Inventor 2814 Art Unit (use as many sheets as necessary) W. Louie Examiner Name H0002312 Attorney Docket Number 1 of 1 Sheet

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Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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*E.CAMINER: Initial if reference considered, whether or rk4 citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901,04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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